



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

941
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In re application of

: **Mail Stop: ISSUE FEE**

Akihisa HONGO et al.

: **Confirmation No. 7681**

Serial No. 09/842,650

: Group Art Unit 1763

Filed April 27, 2001

: Examiner S. Macarthur

REVOLUTION MEMBER SUPPORTING
APPARATUS AND SEMICONDUCTOR
SUBSTRATE PROCESSING APPARATUS

THE COMMISSIONER IS AUTHORIZED
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RESPONSE TO NOTICE REGARDING DRAWINGS

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

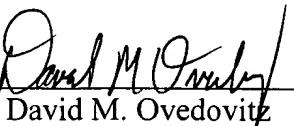
Sir:

In response to the Notice Regarding Drawings mailed on February 17, 2005 for the above-identified application, enclosed herewith are Replacement Figures 1A-78 including the corrections required by the associated Notice of Draftsperson's Patent Drawing Review form. No new matter has been added in these replacement figures. As a result of the submission of these drawings, issuance of the application into a patent is respectfully requested.

Respectfully submitted,

Akihisa HONGO et al.

By



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